

Notice of References Cited	Application/Control No. 10/826,090		Applicant(s)/Patent Under Reexamination CHEN, SHI-SHIEN	
	Examiner Samuel G. Neway		Art Unit 2626	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-5,455,577	10-1995	Slivka et al.	341/51
	B	US-			
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FOREIGN PATENT DOCUMENTS

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NON-PATENT DOCUMENTS

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